

#3/Election  
A

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

5 Applicants: Yi-Fan Chen, Examiner: Huynh, Andy  
Chi-King Pu,  
Shou-Kong Fan  
Filing Date: 04/18/01 Art Unit: 2818  
Serial No.: 09/836,258 Docket No.: NAUP0280USA

2/28/02  
Admith

10 Title: BYPASS CIRCUITS FOR REDUCING PLASMA DAMAGE

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

15 Subject: Response to the Office action dated 01/24/02

Dear Sir:

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FEB 22 2002

**AMENDMENT**

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In response to the Office action identified above,  
please amend the above-identified application as follows:

TECHNOLOGY CENTER 2800

In the claims:

25

Cancel claims 7-14.